



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re the Application of

Masaki KATO et al.

Group Art Unit: 2851

Application No.: 09/828,914

Examiner: H. Nguyen

Filed: April 10, 2001

Docket No.: 109187

For: EXPOSURE APPARATUS, METHOD FOR MANUFACTURING THEREOF AND  
METHOD FOR MANUFACTURING MICRO DEVICE

**AMENDMENT FILED WITH RCE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the April 15, 2003 Final Rejection, and after entry of the Request for  
Continued Examination (RCE) filed herewith, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**

RECEIVED  
JUL 16 2003  
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